

<b>Search Notes</b> 	<b>Application/Control No.</b> 09/530,122	<b>Applicant(s)/Patent under Reexamination</b> NAKAHARA ET AL.
<b>Examiner</b> Mike Qi	<b>Art Unit</b> 2871	

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
349	123 153	8/31/05	2000
	170 124		
149			